

Notice of References Cited	Application/Control No. 10/554,083		Applicant(s)/Patent Under Reexamination JANKA ET AL.	
	Examiner John Hoffmann		Art Unit 1791	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,788,730 A	08-1998	Ruppert et al.	65/17.4
*	B	US-5,393,975 A	02-1995	Hail et al.	250/288
*	C	US-5,567,468 A	10-1996	Lucas, John M.	427/9
*	D	US-5,094,879	03-1992	Matsuda et al.	427/571
*	E	US-2005/0115277 A1	06-2005	Kim et al.	065/417
*	F	US-4,966,614	10-1990	Van Geelen et al.	65/391
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	Q					
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	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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